IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ventor:

Xu, Frank Y.

App. No.:

10/789,319

GPAU:

1712

Filing Date:

February 27, 2004 Examiner:

Marc S. Zimmer

Dkt. No.:

P121-63-03

Conf. No.: 9202

For: Composition for an Etching Mask Comprising a Silicon-

Containing Material

INFORMATION DISCLOSURE STATEMENT

Mail Stop AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure and pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98. The undersigned brings the patents, publications, applications or other information identified in the attached:

\bowtie	Form(s)	PTO/SB/08A	and/or	PTO/SB/08B	or	PTO/1449
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Other:

to the Examiner's attention in the above-identified application. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed:

before the mailing date of a first Office action on the merits or before the mailing date of a first Office action after the filing of a request for continued examination under § 1.114. Therefore, no fee is believed required.

Applicants do not believe that any additional fees are due, but if the Commissioner believes additional fees are due, the

ssioner is hereby authorized to charge any fees which may be quired, or credit any overpayment, to Deposit Account Number 502650.

CERTIFICATE OF TRANSMISSION I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as either First Class Mail or Express Mail, in an envelope addressed to the Commissioner for Patents.

Signed:

Typed Name: Katrina Prati

Respectfully Submitted,

Kenneth C. Brooks, Reg. No. 38,393

Legal Department

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TRASSabstitute for form 1449A/PTO Complete if Known APPLICATION NUMBER 10/789,319 INFORMATION DISCLOSURE FILING DATE 02/27/2004 STATEMENT BY APPLICANT FIRST NAMED INVENTOR Xu et al. Group Art Unit 1712 (use as many sheets as necessary) Examiner Name Zimmer, Marc S. Attorney Docket Number P121-63-03 Sheet

					PATENT DOCU	MENTS				
Examiner Initials*	Cite No. ¹	Foreign Par Office Number		ent Kind Code ⁵ (if known)	Name of Patentee of Cited Docu		Date of Publica Cited Docum MM-DD-YY	nent	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	т
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Signature Considered	Examiner	Date	
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				Group Art Unit	1712			
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Sheet	2	of	5	Attorney Docket Number	P121-63-03			

FOREIGN PATENT DOCUMENTS

Examiner	Cite		ent Document Kind	Code ⁵	Name of Patentee or A			ublication of Document	Pages, Columns, Lines, Where Relevant	T ⁶
Initials*	No. ¹	Office Number	er ⁴ (if k	nown)	Cited Docume	ent		D-YYYY	Passages or Relevant Figures Appear	
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Sheet	3	of	5	Attorney Docket Number	P121-63-03		

				FOREIGN	N PATENT DOCUMENTS			
Examiner Initials*			wment Kind Code ⁵ (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Т	
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Signature	Considered	

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				FIRST NAMED INVENTOR	Xu et al.	
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Sheet	4	of	5	Examiner Name	Zimmer, Marc S.	
	1			Attorney Docket Number	P121-63-03	

Examiner	Cite	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the	Tτ
nitials*	No.1	item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
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Examiner Signature		Date Considered	

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending on the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450.. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Comple	Complete if Known		
				APPLICATION NUMBER	10/789,319		
				FILING DATE	02/27/2004		
				FIRST NAMED INVENTOR	Xu et al.		
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Sheet 5 of 5		Examiner Name	Zimmer, Marc S.				
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OTHER PRIOR	R ART -	- NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
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	B47	Yao et al., Structural, Mechanical and Hydrophobic Properties of Fluorine-Doped Diamond-Like Carbon Films Synthesized by Plasma Immersion Ion Implantation and Deposition (PIII-D), Applied Surface Science 230; pp. 172-178, 4/17/2004					
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Examiner Signature		Date Considered	_				

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3				Attorney Docket Number	P121-63-03	

				U.S. PATENT DOCUMEN	TS	
Examiner Initials*	Cite No.1	U.S. Patent I Number	Nocument Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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STATEMENT BY APPLICANT				FILING DATE	02/27/2004	
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	Data Sheet for	MAK (Methy	I n-Amyl Keton	ne), www.sp-chem.com/fine_	e, 1/1/2003	T	
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C6	Data Sheet for 12/5/2003	gamma-Glyo	cidoxypropyltrir	nethoxysilane, www.powerc	hemical.net/3100.htm,		
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С8		Electronic Devices and Circuits, people.deas.harvard.edu/~jones/es154/lectures/lecture_2/materials/materials.html, 3/31/2005					
C9	Data Sheet for	Data Sheet for Cymel 303ULF, www.cytec.com, 12:00:00 AM					
C10	Data Sheet for	Cycat 4040,	www.cytec.co	m, 12:00:00 AM			
C11	International C www.itcilo.it/er	Chemical Safe nglish/actrav/t	ty Card for p-T elearn/osh/ic/1	oluenseulfonic Acid, 104154.htm, 12/5/2003			
C12	Data Sheet for Edition, 12:00		Ilfonic Acid, NI	OSH Manual of Analytical M	ethods (NMAM), Fourth		
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